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[54] **COATING APPARATUS**
[75] **Inventor:** Masami Akimoto, Kumamoto, Japan
[73] **Assignee:** Tokyo Electron Limited, Tokyo, Japan

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Primary Examiner—Peter Chin
Assistant Examiner—Jacqueline A. Ruller
Attorney, Agent, or Firm—Oblon, Spivak, McClelland, Maier & Neustadt, P.C.

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[57] ABSTRACT

A coating apparatus comprises a spin chuck for holding and rotating a substrate, a header unit movable along a linear line connecting a position just above a center-of-rotation of the substrate, to a home position of the unit, a plurality of nozzles included in the header unit for discharging coating liquids to the substrate held on the spin chuck, the first nozzles having their respective nozzle ports arranged in line along the linear line, and a plurality of coating liquid supply means for supplying the coating liquids to the first nozzles, respectively.

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14 Claims, 5 Drawing Sheets

